



**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2823**

# PATENT

**Customer No. 22,852**

**Attorney Docket No. 04329.3210**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

Takeshi Shibata et al.

**Application No.: 10/743,522**

**Filed: December 23, 2003**

**For: STENCIL MASK WITH CHARGE-UP PREVENTION AND METHOD OF MANUFACTURING THE SAME**

Group Art Unit: 2823

**Examiner: Nguyen, Khiem D.**

**Confirmation No.: 7673**

## Mail Stop AF

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**Sir:**

## **AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed May 14, 2007, the period for response to which extends through August 14, 2007, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment section of this paper.